

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Yamazaki, et al. Art Unit : Unknown
Serial No.: Unknown Examiner : Unknown
Filed : July 26, 2001
Title : PLASMA CVD METHOD

Commissioner for Patents
Washington, D.C. 20231

PRELIMINARY AMENDMENT

Prior to examination, please amend the application as follows:

In the specification:

Please insert the following paragraph on page 1 before "Field of Invention" as follows:

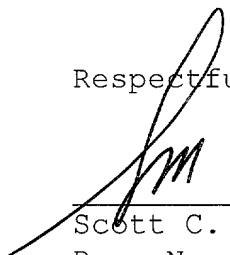
-- This is a continuation of U.S. application serial no. 09/457,128, filed December 7, 1999 (pending), which is a divisional application claiming priority to application serial no. 08/748,233, filed November 12, 1996 (pending). --

Remarks

Applicant asks that all claims be examined. Applicant believes that no fee is due. Please apply any other charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

Date: 7/26/01



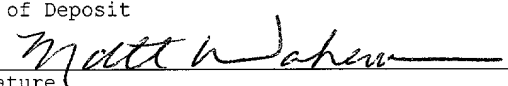
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July 26, 2001

Date of Deposit



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